

CORRECTED COPY

Sheet 1 of 1

FORM PTO-1449 (REV. 7-80)	U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE	ATTY. DOCKET NO. RD-25,905/USA	SERIAL NO. 09/639,636
INFORMATION DISCLOSURE STATEMENT BY APPLICANT <u>LIST OF ITEMS</u>			
Applicant DAVID M. SHADDOCK			
Filing Date 8/15/02			
Group 1722			

U.S. PATENT DOCUMENTS CITED BY EXAMINER ON PTO-892

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
EL	A1 5231655	7-1993	WEI, ET AL	378	147	—
EL	A2 5198680	3-1993	KURAKAKE	378	147	—
EL	A3 5666722	9-1997	TAMM, ET AL	29	847	—
EL	A4 4929256	5-1990	SHEPHERD	51	293	—

U.S. PATENT DOCUMENTS CITED APPLICANT

EL	AA 5557650	9/17/96	GUIDA, ET AL	—	—	—
EL	AB 5581592	12/03/96	ZARNOCH, ET AL	—	—	—

OTHER INFORMATION CITED BY APPLICANT (Including Author, Title, Date, Pertinent Pages, etc.)

EL	BA	AH SMITH, "PHASE MASK MACHINING OR HIGH THROUGHPUT VIA FORMATION", LTEL INSTRUMENTS, PP. 1-6.
EL	BB	B. SMOOTHER, "CYLINDRICAL LENS ARRAYS HOMOGENIZE EXCIMER BEAM", LASER FOCUS WORLD, NOVEMBER 1991, PP. 39.
EL	BC	LAMBDA PHYSIK, "APPLICATION OF EXCIMER LASERS IN ELECTRONIC PACKAGING AND MANUFACTURING", LAMBDA PHYSIK INDUSTRIAL REPORT, 5/96, PUBLICATION NO. 10, PP. 1-8.

EXAMINER		DATE CONSIDERED 4/24/03
EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant		